

<b>Notice of References Cited</b>	Application/Control No. 10/524,569	Applicant(s)/Patent Under Reexamination VAN HELVOIRT ET AL.	
	Examiner MUHAMMAD N. EDUN	Art Unit 2627	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0055247	12-2001	Tateishi et al.	369/44.32
*	B	US-6,259,663	07-2001	Tateishi, Kiyoshi	369/53.12
*	C	US-5,483,510	01-1996	Ogino, Tsukasa	369/44.34
*	D	US-4,785,442	11-1988	Ohtake et al.	369/44.26
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.